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Substitute for form 1449A/PTO				Complete If Known	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				Application Number	
				Filing Date	
				First Named Inventor	Valery Dubin
				Art Unit	
				Examiner Name	
Sheet	2	of	2	Attorney Docket Number	42P14493

OTHER ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>1</sup>
DM	A	GOSSET, et al., "General review of issues and perspectives for advanced copper interconnections using air gap as ultra-low K material", 3 pages, June 2003, Phillips Semiconductors Crolles R&D,	
	A	860 rue Jean Monnet 38920 Crolles France.	
DM	B	NOGUCHI, et al. "Simple Self-Aligned Air-Gap Interconnect Process with Cu/FSG Structure", 3 pages, June 2003, Device Development Center, Hitachi, Ltd., Ome, Tokyo, 198-8512, Japan.	

Examiner Signature		Date Considered	11/26/04
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\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

<sup>1</sup>Applicant's unique citation designation number. <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.

Based on PTO/SB/08B (05-03) as modified by Blakely, Solokoff, Taylor & Zafman (wtr) 05/02/2003.  
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